AFM/STM ACCESSORIES & SUPPLIES

AFM/STM Specimen Preparation, Specimen Storage, Calibration and Consumables



AFM/STM Specimen Discs



PELCO® AFM/STM Diskpenser & Disc Carriers



PELCO[®] AFM/STM Workstation & Disc Grippers



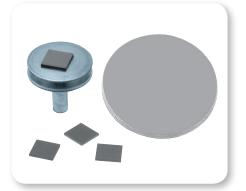
AFM/STM Disc Storage Boxes



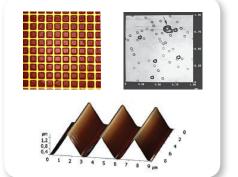
AFM Mounts & Disc Media



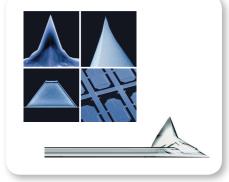
Disc Punches



Silicon Chips & PELCO® Si_3N_4 Discs



AFM Calibration Standards



AFM Probes

Fed Pella, Inc. 07-12-2018, Printed in U.S.A



AFM/STM SUPPLIES & ACCESSORIES

AFM/STM Specimen Discs; Disc Carriers; Disc Pickup Tool; Mica Discs; Glass Coverslips



AFM/STM METAL SPECIMEN DISCS

High quality magnetic stainless steel (alloy 430) discs for Atomic Force Microscopy are offered, with smooth edges and consistently flat surfaces. The AFM/STM discs are 22 gauge which is .0299" (0.76mm) with a range of .0269 to .0329" (0.68 to 0.84mm) thickness. Available in 6, 10,12,15 and 20mm diameter, supplied in packs of 50 in a clear tube which will fit into the PELCO® AFM/STM

Diskpenser (see below).

16223	AFM/STM Specimen Discs, 6mmpkg/50/100/150
16207	AFM/STM Specimen Discs, 10mmpkg/50/100/150
16208	AFM/STM Specimen Discs, 12mmpkg/50/100/150
16218	AFM/STM Specimen Discs, 15mmpkg/50/100/150
16219	AFM/STM Specimen Discs, 20mmpkg/50/100/150

PELCO® GOLD COATED AFM METAL SPECIMEN DISCS

Advanced Nanotechnology Specimen Support



High quality gold coated magnetic stainless steel (alloy 430) discs for Atomic Force Microscopy coated with 1 micron of gold. The discs are supplied in PELCO[®] AFM Disc Carriers. They are available in 10, 12 and 15mm diameter.

	B PELCO [®] AFM Metal Specimen Discs, Gold Coated,	16207-G
each	10mm dia., 10 discs in AFM Disc Carrier	
	B PELCO [®] AFM Metal Specimen Discs, Gold Coated,	16208-G
each	12mm dia., 10 discs in AFM Disc Carrier	
	B PELCO [®] AFM Metal Specimen Discs, Gold Coated,	16218-G
each	15mm dia., 8 discs in AFM Disc Carrier	
	B PELCO [®] AFM Metal Specimen Discs, Gold Coated,	16219-G
each	20mm dia., 4 discs in AFM Disc Carrier	



PELCO® AFM DISKPENSER

A practical way to store and dispense AFM discs. The plastic tubes in which the discs are packaged may be inserted into the PELCO® Diskpenser. With a turn of the cylinder one disc is dispensed, ready to be picked up with the PELCO[®] Disc Gripper as shown to the right. The PELCO® Diskpenser will dispense either 10, 12 or 15mm Discs.

PELCO® AFM Diskpensereach 16204



PELCO® AFM DISC CARRIERS & AFM DISC PICKUP TOOL

An inexpensive way to store 10, 12, 15 and 20mm discs in a dust-free environment. Discs are placed face down into a stepped cavity where the specimen is protected. The cavity allows for a maximum specimen height of 3.2mm (1/8"). They are retrieved by using the convenient PELCO® AFM Disc Pickup Tool, comprised of a plastic handle, stainless steel shaft and a magnetic

pad on the tip. Fingers need not touch the disc. Sliding cover. Box size: 76.2 L x 40 W x 7.5 H (mm) (3" L x 1.58" W x .295" H)

16209	PELCO® AFM Disc Carrier, 10mm, (holds 10)each
16210	PELCO® AFM Disc Carrier, 12mm, (holds 10)each
16214	PELCO® AFM Disc Carrier, 15mm, (holds 8)each
16206	PELCO® AFM Disc Carrier, 20mm, (holds 4)each



16220 PELCO® AFM Disc Magnetic Pickup Tooleach



AFM MICA DISCS

Highest quality grade V1 mica, 0.21mm (.0085") thick. Interleaved, in packages of 10.

Available in four diameters: 10mm (0.39"); 12mm (0.47") 15mm (0.59"); 20mm (0.79")

50	Highest Grade V1 AFM Mica Discs, 10mm pkg/10
50-12	Highest Grade V1 AFM Mica Discs, 12mm pkg/10
50-15	Highest Grade V1 AFM Mica Discs, 15mm pkg/10
50-20	Highest Grade V1 AFM Mica Discs, 20mm pkg/10



ROUND GLASS COVERSLIPS

10mm, thickness #1.5 (0.16 to 0.19mm) sold in package of 100.

12mm, thickness #1 (0.13 to 0.17mm) approx. 173 per 1/4 oz.

15mm, thickness #1 (0.13 to 0.17mm) approx. 111 per 1/4 oz.

260368	Coverslips, Glass, 10mm dia pkg/100
26023	Coverslips, Glass, 12mm dia1/4 oz
26024	Coverslips, Glass, 15mm dia1/4 oz



AFM Work Station; Disc Grippers; Disc Storage Boxes; AFM Sample Holders; 3mm Discs



PELCO[®] ATOMIC FORCE MI-CROSCOPY WORKSTATION

Turned from solid aluminum, this workstation features an adjustable internal magnet to securely hold a metal AFM Specimen Disc in place. A tray around the circumference of the central disc holder may be used to catch residue or hold additional discs.

15010PELCO® AFM Workstation....each16220PELCO® AFM Disc Pickup Tool (previous page)each



PELCO® AFM DISC GRIPPERS

Specially designed rubber coated tips for picking up AFM discs from a flat surface. Transfer Atomic Force Microscopy Discs from Diskpenser to PELCO® AFM Workstation to Microscope and to PELCO® AFM Disc Carrier or AFM Disc Storage Box with ease.



1071	
1668	PELCO [®] 12mm AFM Disc Gripperseach
1669	PELCO [®] 15mm AFM Disc Gripperseach
1672	PELCO [®] 20mm AFM Disc Gripperseach

PELCO® SILICON NITRIDE COATED 3MM DISCS



These 3mm blank silicon discs have a 50nm ultra low stress silicon nitride layer (Si₃N₄) on both sides and can be used as specimen discs for AFM applications which need a Si₃N₄ background. Provide smooth background: Surface roughness has RMS (Rg) of 0.65 \pm 0.06nm which gives a mean roughness (RA) of 0.45 \pm 0.02nm

Film Thickness: 50nm ultra low stress Si_3N_4 on both sides Disc Thickness: 200 μ m silicon support Disc Diameter: 3mm

Surface Roughness: The RMS (Rq) is 0.65 ±0.06nm which gives a mean roughness (Ra) of 0.45 ±0.02nm Packaging: The PELCO[®] Silicon Aperture Frames are packaged under cleanroom conditions in the PELCO[®] #160 TEM Grid Storage box. Each box holds 10 discs.

21555-10 PELCO® Silicon Nitride 3mm Discs pkg/10

CROSS SECTION AFM MOUNTS & AFM SAMPLE HOLDERS

A convenient way to clamp and position cross sectional samples for AFM imaging. These holders are all made from high quality magnetic stainless steel (alloy 430) so they can be easily attached to the magnetic sample holder of the AFM system. Small 12mm diameter will make the cross section holders compatible with most AFM systems on the market.



PELCO® X-TREME AFM/STM DISC STORAGE BOX



Very strong and rugged clear polycarbonate box to store stainless steel AFM discs with 6, 10, 12, 15 or 20mm diameter. The PELCO® X-TREME storage box is watertight, crushproof and dustproof. Strong hinges, locking clasps and O-ring seal makes this box suitable for transport, shipping and storage of the stainless steel AFM

discs. Ideal for storing calibration and test samples. The box has a single pole magnetic layer in the base with a size of 47 x 86mm (1.85" x 3.4"). A marker pen can be used to write on the magnetic material. OD 112 x 77 x 36mm (4.4" x 3" x 1.4"), maximum specimen height is 21mm (0.81").

Storage capacity: 5 ea of the Ø20mm AFM discs: 8 ea of the Ø15mm AFM discs; 10 ea of the Ø12mm AFM discs; 21 ea of the Ø6mm AFM discs.

16224 PELCO® X-TREME AFM Disc Storage Boxeach

PELCO® AFM DISC STORAGE BOXES

These storage boxes have a single pole magnetic layer in the base of the box to store stainless AFM discs with 10, 12, 15 or 20mm diameter.

Large storage box holds up to 20 AFM discs. Inside measurements of the styrene box are 152 x 51 x 18mm (6" x 2" x 11/16"). Box has a clear lid and a black base.

Small storage box holds up to 4 discs. Inside measurements of the styrene box are 70 x 28 x 18mm (2-3/4" x 1-1/8"x 11/16"). Box has a clear lid and a blue base.

 16201
 PELCO® Single AFM/STM Disc Storage Box, Small pkg/5

 16203
 PELCO® AFM Disc Storage Box, smalleach

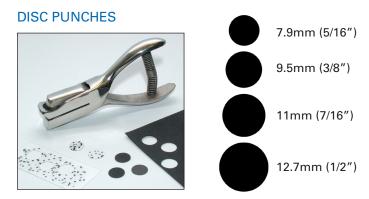
 16212
 PELCO® AFM Disc Storage Box, largeeach





AFM SUPPLIES & ACCESSORIES

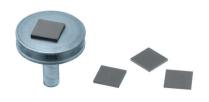
Disc Punches; Silicon Chips; AFM Cantilever Tweezers; Gold Coated Slides & Coverslips



Maximum thickness for punching: 0.067" (1.7mm)

each	Disc Punch, 7.9mm Ø circle (5⁄16″).	54740
each	Disc Punch, 9.5mm Ø circle (3⁄8")	54741
each	Disc Punch, 11mm Ø circle (3⁄16")	54742
)each	Disc Punch, 12.7mm Ø circle (5/16")	54743

SILICON CHIP SPECIMEN SUPPORTS



Si-chips are opaque, of low electrical resistance and have surface properties equal to glass (including smoothness). They are chemically inert and make good substrates for growing or mounting cells. Si-

chips are precleaned before packaging. Also ideal for imaging small particles due to low background signal.

Availability: 4" wafer is precut into 5×7 mm, 5×5 mm or 10×10 mm chips that can be easily separated in the laboratory.

Properties: Orientation (111) Resistance 1-30 Ohms Type P (Boron) (1 primary flat) No SiO2 top coating Wafer thickness is 18-21 mil Wafer is polished on one side After dicing they are rinsed in DI water for cleaning

16007	4″ (10cm) dia., 5 x 7mm diced Silicon Wafer, 187 chips/wafereach
16008	4" (10cm) dia., 5 x 5mm diced Silicon Wafer, 270 chips/wafereach
16006	4" (10cm) dia., 10 x 10mm diced Silicon Wafer, 55 chips/wafereach

AFM CANTILEVER TWEEZERS - STAINLESS STEEL



Easily grasp AFM cantilevers / probes with these precise nonmagnetic stainless steel, tweezers. 4-58" (117mm) long.



5599 AFM Cantilever Tweezers, NM-SSeach

PELCO® GOLD COATED MICROSCOPE SLIDES



High quality glass, standard microscope slides coated with 50nm of gold with a 5nm chromium adhesion layer between the glass slide

surface and the gold coating. Can be used for a wide range of nanotechnology, biotechnology and AFM applications. Also suitable as an opaque microscopy support. Both Cr and Au are evaporated on the glass slide using a vacuum evaporation system. The gold surface is not atomically flat, but has bumps in the nm range. The gold slides are individually packed in a slide mailer. The gold slides are autoclavable.

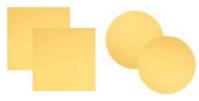
Glass Slide: 75 x 25mm , 1mm thickness, soda lime glass

Chromium Adhesion Layer Thickness: 5nm

Gold Layer Thickness: 50nm (+/- 5nm)

26002-G Gold Coated 75 x 25mm Microscope Slide, 50nm Au ..each

PELCO® GOLD COATED MICROSCOPE SLIDES



High quality, borosilicate glass coverslips coated with 50nm of gold with a 5nm chromium adhesion layer between the coverslip surface and the gold coating. Can be used for

a wide range of nanotechnology, biotechnology and AFM application. Both Cr and Au are evaporated on the glass coverslips using a vacuum evaporation system. The gold surface is not atomically flat, but has bumps in the nm range. The coverslips are sold in packs of 2 and are packed in an X0 Gel-Pak box. The gold coated coverslips are autoclavable.

Glass Coverslip Size: Ø16mm with thickness #1 or 22 x 22mm with thickness #2

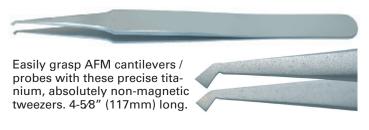
Glass Type: Schott D263M borosilicate

Chromium Adhesion Layer Thickness: 5nm

Gold Substrate Layer Thickness: 50nm (±5nm)

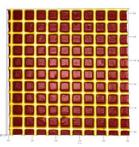
260156-G Gold Coated 22 x 22mm Glass Coverslips, 50nm Au ...each 260374-G Gold Coated Ø16mm Glass Coverslips, 50nm Aueach

AFM CANTILEVER TWEEZERS - TITANIUM



5596-TI AFM Cantilever Tweezers, Titaniumeach

2000 LINES/MM CROSS LINE GRATING REPLICA



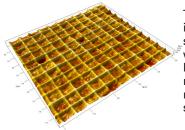
2,000 lines/mm cross line grating replica is suitable for X-Y calibration. The replicas have well-defined trench type grooves, which makes it easy to determine the 500nm pitch.

The 677-AFM Grating Replica is made of cellulose acetate. It replaces the previous #607-AFM Grating Replica with 463nm pitch.

The 677-STM Grating Replica is a carbon replica with Au/Pd shadowing supported on a 400 square mesh, 3mm copper TEM grid which is mounted on a 12mm disc. It replaces the previous #607-STM Grating Replica with 463nm pitch.

- 677-AFM X-Y Cross Line Grating Replica, 2000 lines/mm, Cellulose . Acetate, Mounted on 12mm Specimen Disc.....each
- 677-STM X-Y Cross Line Grating Replica, 2000 lines/mm, Carbon/..... Au/Pd Coated, Mounted on 12mm Specimen Disc......each

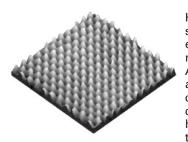
2,160 WAFFLE GRATING REPLICA FOR STM



The 607-STM Grating Replica is a carbon replica with Au/Pd shadowing for X-Y calibration with 2,160 lines/mm crossed lines. Made on a 400 square mesh, 3mm copper TEM grid; mounted on a 12mm stainless steel STM disc.

607-STM X-Y Cross Line Grating Replica, Carbon/Au/Pd Coated, mounted on 12mm specimen disceach

HIGHLY ORIENTED PYROLYTIC GRAPHITE – HOPG



HOPG is widely used as a substrate for specimens to be examined in scanning probe microscopes (SPM, STM and AFM). It may also be used as a calibration specimen. HOPG consists of layered planes of carbon atoms (002) which are highly oriented with respect to each other. This prarallel is

characterized by the mosaic spread angle.

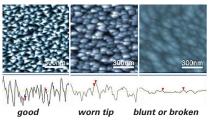
HOPG grade ZYB with a mosaic spread of 1.2° \pm 0.2° with a grain size of up to $1\mu m$

626-1 HOPG grade ZYB, 10 x 10mm x 2mm.....each

TipChecker FOR AFM PROBES

When imaging a sample by AFM, it is imperative to know the condition of the AFM probe, since this determines the quality and correctness of the image. The TipChecker is an SPM sample for fast, convenient and efficient determination of the AFM tip condition. The clear differences between the tips becomes apparent even with a single scan line. The TipChecker offers a fast and easy way to compare and categorize differ-

ent AFM tips with respect to tip apex, shape and sharpness. The TipChecker sample enables checking if the tip is still good, starts showing wear or is blunted or broken without the need for scanning an entire image or using SEM inspection. The Tip Checker sample works perfectly with Auto Tip Qualification and Tip Characterization software that is available on the market.

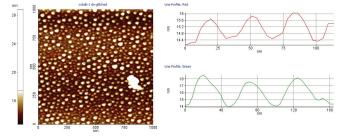


Figures showing a comparison between different AFM probe tips used to image the Tip-Checker sample. Scan is $1 \times 1 \mu m$ for all images, height is 100nm. Each image is shown with a representative crosssection scan.

The BudgetSensors TipChecker sample consists of an extremely wear-resistant thin film coating deposited on a silicon chip. The thin film coating shows a granular, sharply peaked nanostructure ideal for reversely imaging an AFM probe's apex. The die size of the BudgetSensors TipChecker is 5x5mm and is completely coated with the thin film. It comes glued onto a 12mm diameter, stainless steel, magnetic disc, ready to be placed into your AFM set.

TC1 BudgetSensors TipChecker for AFM Probes.....each

PELCO® TIP & RESOLUTION TEST SPECIMEN



This product is intended for checking the tip sharpness (not height calibration); AFM tips wear down and can get damaged resulting in blurry lines, especially at the nano scale.

A single layer of cobalt particles provide an excellent and stable substrate for AFM tip characterization and instrument operation. Image at top demonstrates height calibration at 1nm (red line profile) and 3nm (green line profile) on the standard to indicate a sharp tip. Can be used in water as long as there are no chemicals present which would react with the substrate or the Co particles.

The Co particles are flattened half spheres (droplets) with the radius typically larger than the height. There is a distribution of particle heights between 1 and 5nm.

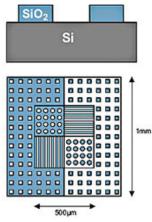
Available on 5x5mm silicon wafer chips, unmounted or mounted, on 12mm stainless steel metal disc. Tip characterization down to angstrom resolution is easily attained. Readyto-scan test specimen.

628	PELCO [®] AFM Tip and Resolution Test Specimen,	
	Unmounted	each
628-AFM	PELCO [®] AFM Tip and Resolution Test Specimen,	
	Mount AFM	each



HS-SERIES AFM CALIBRATION STANDARDS

Step heights of 20, 100 or 500nm.



The HS-series calibration standards offers an easy and reliable way to calibrate AFM systems. Primarily designed for accurate Z-axis calibration, the standards also offer X- and Y-axis calibration for bigger scanners in the 40-100 μ m range. The structure symmetry enables calibration without the need to rotate and re-align the sample in between X- and Y-axis calibration.

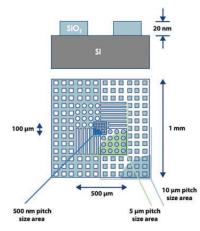
The HS-series feature silicon dioxide structure arrays on a 5 x 5mm silicon chip. The fabrication process ensures excellent uni-

formity of the structures across the chip. There are three step heights available with nominal values of: 20nm, 100nm, and 500nm. The actual value will be supplied with the delivered calibration standard. Arrays of structures with different shape and pitch are integrated on the chip. The larger square of 1 x 1mm contains square pillars and holes with a 10 μ m pitch. The smaller center square of 500 x 500 μ m contains circular pillars and holes as well as lines in both X- and Y-direction with a 5 μ m pitch.

The silicon chips are available unmounted or mounted on a 12mm standard AFM disc using a high quality electrically conductive epoxy.

HS-20MG	AFM Calibration Standard, step height 20nm, mountedeach
HS-20MG-UM	AFM Calibration Standard, step height 20nm, unmountedeach
HS-100MG	AFM Calibration Standard, step height 100nm, mountedeach
HS-100MG-UM	AFM Calibration Standard, step height 100nm, unmountedeach
HS-500MG	AFM Calibration Standard, step height 500nm, mountedeach
HS-500MG-UM	AFM Calibration Standard, step height 500nm, unmountedeach

CS AFM XYZ CALIBRATION STANDARD



The CS-20NG represents an advanced XYZ calibration grid that enables reliable calibration of AFM systems down to the nanometer level. The XYZ calibration standard features silicon dioxide structures on a 5 x 5mm silicon chip. The calibration area is in the middle of the chip and can be easily located by the optical system of the AFM. The structure step height is in the range of 20nm. The actual height value will be supplied with the delivered

calibration standard. CS-20NG has three different x-y array sizes, all with the same 20nm height. The large 1 x 1mm square contains square pillars and holes with a 10 μ m pitch.

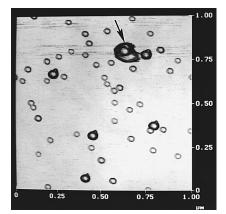
The middle square contains circular pillars, holes and lines with a 5μ m pitch. The small central area contains circular holes with a 500nm pitch. The CS-20NG is suitable for both lateral and vertical AFM scanner calibration. The structure symmetry enables calibration in one step without the need to rotate the sample between X- and Y-calibration.

Vertical accuracy is 2% of the actual value which corresponds to ± 0.4 nm. The lateral pitch accuracy for the 5µm and 10µm patterns is 0.1µm. For the 500nm pitch region, the lateral accuracy is 10nm.

The XYZ calibration standard is mounted on a 12mm, standard AFM disc using a high quality electrically conductive epoxy resin.

CS-20NG AFM XYZ Calibration Standard, mounted on a 12mm AFM disceach

AFM GOLD CALIBRATION KIT



Characterized colloidal gold particles for:

- Characterization
 of scanning tip
 geometry
- Reliable calibration of the vertical scale of piezoelectric response
- Characterizing vertical dimensions of coadsorbed biomolecules

Three sizes of colloidal gold particles are available in a convenient kit form. The kit contains 8 numbered 15mm AFM discs with mica attached for calibration and tip characterization. Remaining colloidal gold can be used for coadsorption with biomolecules or other samples.

16200 and 16205 Kits Contain:

PELCO® 15mm AFM Disc Carrier

15mm AFM Discs, numbered with 9.9mm Mica Discs attached, 8 ea., in a 16214 PELCO® Disc Carrier

PELCO® AFM Disc Pickup Tool

Gold Colloid, 5nm Range, 500µl

Gold Colloid, 15nm Range, 500µl

Gold Colloid, 30nm Range, 500µl

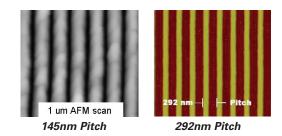
Poly-L-Lysine, 0.1%, 500µl

Protocol & Reprint (see below)

16200	PELCO® AFM Gold Standard Kiteach
16205	PELCO [®] AFM Gold Standard Kit with 2 Additional
	Gold Sizes (10 and 20nm Range)each

Vesenka J, Manne S, Giberson R, Marsh T, and Henderson E, 1993. Colloidal Gold Particles as an Incompressible Atomic Force Microscope Imaging Standard for Assessing the Compressibility of Biomolecules. Biophysical Journal 65:1-6





HIGH MAGNIFICATION, HIGH RESOLUTION REFERENCE & CALIBRATION STANDARDS

Holographic Grating for AFM, SEM, Auger and FIB

Precision, holographic patterns, provide accurate calibration and feature high stability and usability. Moderate ridge heights are convenient for AFM. Specimens provide good contrast for secondary and backscatter imaging with SEM. They enable accurate calibration for high resolution, nanometer-scale measurements. Available with 70, 145 and 292nm pitch.

145nm Pitch Reference Standard for Very High Resolution Calibration

Precision holographic pattern for accurate calibration for high resolution, nanometer scale measurements.

Period: 145nm pitch nominal, one dimensional array. Accuracy is +/- 1nm. Calibration certificate will give the actual pitch of the standard.

Surface Structure: Aluminum lines on glass, 4 x 6mm dimensions. Line height (about 100nm) and line width (about 75nm) are not calibrated.

Usability: The calibrated pattern covers the entire standard. There is sufficient usable area to make tens of thousands of measurements without reusing any areas contaminated or altered by previous scans.

AFM: Use in contact, tapping and other modes with image sizes from 250nm to $10\mu m.$ Available unmounted or mounted on a 12mm steel AFM disc.

Certification: Comes with a non-traceable manufacturer's certificate stating average pitch, based on batch measurements.

642-1AFM	145nm Very High Resolution AFM Reference Standard
	on 12mm steel disceach
642-1	145nm Very High Resolution AFM Reference Standard,
	Unmountedeach

292nm Pitch High Magnification, High Resolution Calibration Standard

Precision holographic grating standard with high contrast and excellent edge definition.

Period: 292nm pitch nominal, one dimensional array. Accuracy is +/- 1%. Calibration certificate will give the actual pitch of the standard.

Surface Structure: Titanium lines on Silicon, 4 x 3mm dimensions. Line height (about 30nm) and line width (130nm) are not calibrated.

Usability: The calibrated pattern covers the entire chip. There is sufficient usable area to make tens of thousands of measurements without reusing any areas contaminated or altered by previous scans.

AFM: Use in contact, tapping and other modes with image sizes from 500nm to $20\mu m$. Mounted on a 12mm steel AFM disc.

Certification: There is a version with a non-traceable manufacturer's certificate stating average pitch, based on batch measurements.

There is also the traceable, certified version measured in comparison with a standard calibrated at PTB (Physiklisch-Technischen Bundesanstalt in Braunschweig, Germany, is the German counterpart of NIST). The standard is NIST traceable by virtue of the mutual recognition agreement by NIST and PTB.

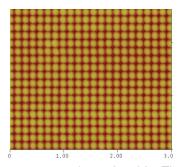
643-1AFM	292nm High Resolution AFM Reference Standard
	on 12mm steel disc, Certifiedeach
643-1	292nm High Resolution AFM Reference Standard,
	Unmounted, Certifiedeach
643-11AFM	292nm High Resolution AFM Reference Standard
	on 12mm steel disc, Certified, Traceableeach
643-11	292nm High Resolution AFM Reference Standard,
	Unmounted, Certified, Traceableeach



2D HOLOGRAPHIC ARRAY STANDARDS

Precision, holographic pattern providing accurate calibration in the horizontal plane for very high resolution, nanometerscale measurements with 144nm and 300nm pitch.

144nm Very High Resolution 2D Calibration Standard



Period: 144nm pitch, twodimensional array. Accurate to ± 1 nm. Refer to calibration certificate for actual pitch.

Surface: Aluminum bumps on Silicon, 4 x 3mm die. Bump height (about 90nm) and width (about 75nm) are not calibrated.

Usability: The calibrated pat-

tern covers the entire chip. There is sufficient usable area to make tens of thousands of measurements without reusing any areas altered or contaminated by previous scans.

AFM: Use in contact, intermittent contact (TappingMode[™]) and other modes with image sizes from 250nm to 10mm. Available unmounted or mounted on 12mm steel discs.

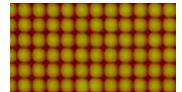
SEM: This specimen works well at all accelerating voltages. Normally supplied unmounted. Can be mounted on a stub of your choice.

Model 2D: This Calibration Reference specimen comes with a non-traceable, manufacturer's certificate. This states the average period, based on batch measurements.

Model 2DUTC: This Traceable, Certified Standard is a select grade. Each standard is individually measured in comparison with a similar specimen calibrated at PTB. (PTB, Physikalisch-Technischen Bundesanstalt, is the German counterpart of NIST.) The uncertainty of single pitch values is typically ±1.4nm (95% confidence interval). Multi-pitch measurements provide the usual square-root of N improvement in precision.

16465-2D	144nm 2D Pattern Calibration Standard, Unmounted, Certifiedeach
16465-2D-AFM	144nm 2D Pattern Calibration Standard on 12mm steel disc, Certifiedeach
16465-2DUTC	144nm 2DUTC Pattern Calibration Standard, Unmounted, Certifiedeach
16465-2DUTC-AFM	144nm 2DUTC Pattern Calibration Standard, on 12mm steel disc, Certified, Traceableeach

300nm Very High Resolution 2D Calibration Standard



Period: 300nm pitch nominal, one dimensional array. Calibration certificate will give the actual pitch of the standard.

Surface Structure: Aluminum bumps on Silicon, 4 x 3mm) and width (about 150nm)

die: Bump height (about 50nm) and width (about 150nm) not calibrated.

Usability: The calibrated pattern covers the entire chip. There is sufficient usable area to make thousands of measurements without reusing any areas contaminated or altered by previous scans.

AFM: Use in contact, tapping and other modes with image sizes from 500nm to 20nm. Mounted on a 12mm steel AFM disc.

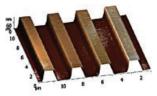
SEM: Auger, FIB: Can be used for a wide range of accelerating voltage (1kV-20kV) and calibrates images from 5kX to 200kX. Can be supplied unmounted or mounted on an SEM stub of your choice. SEM Mount selection A-M.

Certification: Supplied with a non-traceable manufacturer's certificate stating average pitch, based on batch measurements.

16475-1AFM	300nm 2D Resolution AFM Reference Standard on a 12mm steel Disc, Certifiedeach
16475-1	300nm 2D Resolution AFM Reference Standard on a 12mm steel Disc, Certifiedeach

AFM, STM, SPM CALIBRATION SPECIMENS

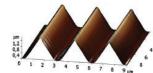
A complete selection of useful, precise, practical calibration and test specimens for scanning probe microscopy (SPM, AFM and STM) applications. Included are calibration specimens for Z-axis, X- or Y-axis, X/Y/Z direction, linearity and tip sharpness parameters.



Block Test Gratings for Z-axis

Selection of 3 block type test gratings with different step heights intended for Z-axis calibration of scanning probe microscopes and linearity measurements.

Structure:	Si Wafer with SiO ₂ layer for grating		
Pattern Type:	1-Dimensional (in Z-axis direction)		
Step Heights:	20±1nm for TGZ-20; 115±2nm for TGZ-100;		
	550±3nm for TGZ-500		
Period:	3 ±0.01µm		
Chip Size:	5 x 5 x 0.5mm		
Effective Area:	Central square of 3 x 3mm		
629-10 629-10AFM	Calibration grating TGZ-20, Z=18.5nmeach Calibration grating TGZ-20, Z=18.5nm, mounted on 12mm AFM disceach		
020 .0	Calibration grating TGZ-20, Z=18.5nm, mounted on		
629-10AFM	Calibration grating TGZ-20, Z=18.5nm, mounted on 12mm AFM disceach		



Triangular Test Grating for X- or Y-axis

The TGT-1500 test grating is intended for SPM calibration in Xor Y-axis, determination of lateral

and vertical scanner nonlinearity, detection of angular distortion and tip characterization, $3\mu m$ pitch.

Structure:	Si wafer with grating in top surface	
Pattern Type:	1-D array of triangular steps with precise	
	linear and angular dimensions	
Edge Angle:	Aprox. 70 degrees	



AFM SUPPLIES & ACCESSORIES

AFM Calibration Specimens

Edge Radius:	≤10nm
Pattern Height:	1.8µm (non-calibrated for information only)
Period:	3 ±0.01µm
Chip Size:	5 x 5 x 0.5mm
Effective Area:	Central square of 3 x 3mm

 629-40
 Test grating TGT-1500, 3μm pitcheach

 629-40AFM
 Test grating TGT-1500, 3μm pitch, mounted on

 12mm AFM disc......each



Test Grating for Tip Sharpness

The TGTZ-400 test grating is intended for 3-D visualization of the scanning tip, determination of tip sharpness parameters, tip degradation and contamination control.

Structure:	Si wafer with grating in top surface		
Pattern Type:	Array of sharp tips		
Tip Angle:	About 50 degrees		
Tip Radius:	≤10nm		
Tip Height:	0.3 - 0.7µm		
Period:	3 ±0.01µm		
Diagonal Period: 2.12µm			
Chip Size:	5 x 5 x 0.5mm		
Effective Area:	Central square of 2 x 2mm		
629-50 629-50-AFM	Test grating TGTZ-400, 300-700nm tipseach Test grating TGTZ-400, 300-700nm tips, mounted		



Test Grating for Lateral Calibration

on 12mm AFM disc each

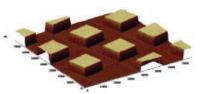
The TG3D-3000/600 test grating with its 3-Dimensional array is intended for lateral calibration of SPM scanners, detection of lateral nonlinearity, hysteresis,

creep, cross-coupling effects and for determination of the tip aspect ratio.

Structure:	Si wafer with grating in top surface	
Pattern Type:	Chessboard like array of square	
	pillars with sharp undercut edges	
Height:	0.3 - 0.6µm	
Top Square Size: 1.2 x 1.2μm		
Edge Radius:	≤10nm	
Period:	3 ±0.05µm	
Chip Size:	5 x 5 x 0.5mm	
Effective Area:	Central square of 3 x 3mm	

Note: Height and top square dimensions are given for information only (non calibrated values).

629-60	Test grating TG3D-3000/600, pillarseach
629-60-AFM	Test grating TG3D-3000/600, pillars, mounted on
	12mm AFM disceach



Test Grating for X-, Yand Z-direction

The TG3D-3000/20 test grating with its truly 3-Dimensional structure is intended for simultaneous

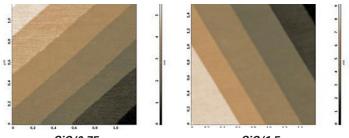
calibration in X-, Y- and Z-direction, lateral calibration of SPM scanners and detection of any lateral nonlinearity, hysteresis, creep and cross-coupling effects.

Structure:	Si wafer with SiO ₂ layer for grating	
Pattern Type:	3-Dimensional array of small squares	
Height:	20 ±1.5nm	
Square Size:	1.5 ±0.15μm	
Period:	3 ±0.05µm	
Chip Size:	5 x 5 x 0.5mm	
Effective Area:	Central square of 3 x 3mm	

Note: The precision on the height is based on the measurement of 5 gratings (randomly selected from a batch of 300 gratings) by an SPM calibrated by a PTB certified TGZ-20 grating. The basic step height can vary from the specified one within 10% (example: step height can be 22 ± 1.5 nm).

629-70	Test grating TG3D-3000/20, squaresea	ch
629-70-AFM	Test grating TG3D-3000/20, squares, mounted on	ı
	12mm AFM discea	ch

Si-STEP Calibration Sample



SiC/0.75

SiC/1.5

6H-SiC (0001) based calibration sample which is designed to perform easy calibrations of an AFM scanner vertical movements in several nanometers interval. The simplicity of calibration of the calibration process is provided by the nearly uniform distribution of half-monolayer high steps (either 0.75 or 1.5nm) on the sample surface demonstrating both chemical and mechanical stability. The step height corresponds to the half of the lattice constant of the 6H-SiC crystal in the (0001) direction.

Structure:		SI with steps
Single Step He	ight:	0.75nm / 1.5nm
Average Inter-step Distance:		0.15-0.4µm / 0.2-0.5µm
Mis-orientation of Surface:		~0.2° / ~0.3°
Average Inter-step Roughness:		0.09nm
Chip Size:		5 x 5 x 0.3mm
629-85		ion Sample with 0.75nm Step deach
629-85-AFM	SiC-STEP Calibration Sample with 0.75nm Step	
629-90	SiC-STEP Calibrat	on 12mm AFM disceach ion Sample with 1.5nm Step deach
629-90-AFM	0,	ion Sample with 1.5nm Step

height, mounted on 12mm AFM disc......each

10 www.tedpella.com

0.3mm

AFM's as it has industry standard size. It is compatible with DI Nanoscope, PSI, JEOL, NT-MDT, Asylum, VEECO, WiTec and other commercial AFM's

The AFM Holder Chip fits most commercial

The AFM Cantilever is micromachined monolithic Silicon, comprising excellent uniformity. It provides high quality imaging for all standard AFM's.

con probe, exhibiting excellent uniformity and a sharp tip radius. The consistent tip radius of less than 10nm gives good resolution and reproducibility. The probes (except the Silicon Nitride tip) feature an "on scan angle" symmetric tip to provide a more symmetric representation of features over 200nm.

Some AFM systems, such as NanoScale, require alignment grooves on the back side of the AFM holder chip for correct holding and calibration of each AFM probe. All products with alignment grooves have "-G" in their product number. Available AFM Probes with alignment grooves are: Tap150-G; Tap190-G; Multi75AI-G; Multi75E-G; Multi75M-G; ContAI-G and Electri-G.

available with a variety of coatings to give the highest resolution needed for cutting edge nanoscale imaging.

Please Note: The presence of the alignment Grooves does not affect the AFM probe in systems that do not require this feature. AFM probes with grooves have the same specifications and pricing as the equivalent probes without alignment grooves.

The right choice of AFM probes is extremely important for the quality of your AFM work. The BudgetSensors AFM probes are an excellent choice for today's high demands in nanotech research. Designed by specialists in AFM, they combine the latest technology of AFM tip/cantilever manufacturing with a realistic pricing. Made of monolithic silicon, they fit into most commercially available AFM's (DI nanoscope, PSI, JEOL, NT-MDT, Asylum, VEECO, WiTec, etc) and outperform all other silicon AFM probes on the market when it comes to value, sharpness, symmetry and consistency. The BudgetSensors AFM probes are specifically designed for different AFM modes and are

Order a combination of whatever probes you want. BudgetComboBox on the web page gives you the freedom to choose freely your personalized box with AFM probes out of any available BudgetSensors AFM Probe models you need.

NEW! Budget Sensors TipChecker, an SPM sample for fast, convenient and efficient determination of the AFM tip condition.

AFM probes are all available with some or all of the following high quality coatings (depending on series):

ΑΙ Aluminium coating of the cantilever for enhanced reflectivity

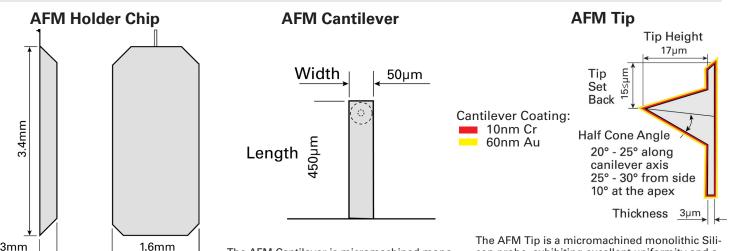
Tap190G series with longer cantilever for tapping mode

Contact series for contact mode and pulse force mode

Magnetic AFM Probe, an excellent choice for MFM applications

- Electri Chromium/Platinum electrically conductive coating for Electric Modes
- GD Partial gold coating of the cantilever for enhanced reflectivity for special applications such as in liquids
- GB Overall gold coating of the cantilever where the probe acts as an electrode
- Μ Magnetic Coating
- DLC Diamond-like-Coating on tip side of cantilever

Technical information and dimensions for the BudgetSensor AFM holder, cantilever and tip:



If there are any doubts regarding compatibility of your AFM system with the BudgetSensors AFM probes,



please contact us at sales@tedpella.com.

• Tap300 series for tapping mode Tap150G series for soft tapping mode

Multi75 series for force modulation mode

New! All-In-One series with four cantilevers

Silicon AFM probes products:

.

•

•



🖊 TED PELLA, INC.